

Advances in Mathematics

Edited by

Michael J. Hopkins, Johan de Jong, Tomasz S. Mrowka, and Gang Tian
Massachusetts Institute of Technology, USA

Advances in Mathematics
Elsevier Editorial Office
525 B Street, Suite 1900
San Diego, CA 92101-4495, USA
E-mail: aim@elsevier.com
Telephone: (619) 699-6854
Fax: (619) 699-6700

Editorial Board

Alexandra Bellow
Northwestern University
Evanston, IL 60201, USA

David J. Benson
Department of Mathematical Sciences
University of Aberdeen
Aberdeen, AB24 3UE, Scotland, UK

David Ben-Zvi
Mathematics Department
University of Texas at Austin
Austin, TX 78712-0257, USA

Sara C. Billey
Department of Mathematics
University of Washington
Seattle, WA 98195-4350, USA

Anders Björner
Kung. Tekniska Högskolan
S-10044 Stockholm, Sweden

Felix Browder
Hill Center, Bush Campus
Rutgers University
New Brunswick, NJ 08903, USA

Luis Caffarelli
RLM 8.100
University of Texas at Austin
Austin, TX 78712, USA

Alain Connes
Institut Hautes Études Scientifiques
35, Rue de Chartres
91440 Bures-sur-Yvette, France

Andreas Dress
Postfach 8640
Universität Bielefeld
D-4800 Bielefeld 1, Germany

Pavel Etingof
Massachusetts Institute of Technology
Cambridge, MA 02139-4307, USA

Charles Fefferman
Princeton University
Princeton, NJ 08544, USA

Daniel S. Freed
University of Texas at Austin
Austin, TX 78712, USA

Adriano Garsia
University of California, San Diego
La Jolla, CA 92037, USA

I.M. Gelfand
Rutgers University
New Brunswick, NJ 08903, USA

Melvin Hochster
University of Michigan
Ann Arbor, MI 48109, USA

Mark Hovey
Wesleyan University
Middletown, CT 06459, USA

Vaughan Jones
University of California, Berkeley
Berkeley, CA 94720, USA

André Joyal
Université du Québec à Montréal
CP 8888, Succursale "A"
Montréal, PQ, Canada H3C 3P8

Ludmil Katzarkov
University of California, Irvine
Irvine, CA 92697, USA

Takahiro Kawai
Research Institute for Mathematical Sciences
Kyoto University
Kitashirakawa, Sakyo-ku Kyoto 60601
Japan

H. Jerome Keisler
University of Wisconsin
Madison, WI 53706-1388, USA